

YOR920010368US2

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re patent application of

N. Bojarczuk Jr., et al.

Serial No.: 10/059,422

Group Art Unit: 2814

Filed: January 31, 2002

Examiner: Theresa Doan

For: METHOD OF FORMING LATTICE-MATCHED STRUCTURE ON SILICON AND
STRUCTURE FORMED THEREBY

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

PETITION AND FEE FOR EXTENSION OF TIME
UNDER 37 C.F.R. 1.136(a)

Sir:

Applicant hereby petitions for a one-month extension of time to respond to the Office Action mailed March 31, 2003. The Commissioner is authorized to charge Assignee's Deposit Account No. 50-0510 in the amount of \$110.00 to cover the extension fee. A duplicate copy of this sheet is enclosed. An Amendment responsive to the outstanding Office Action is being filed simultaneously herewith.

The Commissioner is authorized to charge any deficiencies in fees and credit any overpayment of fees to Assignee's Deposit Account No. 50-0510.

Respectfully submitted,



Sean M. McGinn, Esq.
Reg. No. 34,386

Date:

7/31/03

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